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Bib Data Sheet

SERIAL NUMBER 09/594,502	FILING DATE 06/16/2000 RULE —	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. 47408-20007.00	
APPLICANTS Tomohiro Hashii, Imari-shi, JAPAN; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 11-170860 06/17/1999 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/28/2000 —					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 3	INDEPENDENT CLAIMS 1
ADDRESS Morrison & Foerster LLP 2000 Pwennsylvania Avenue N W Washington ,DC 20006-1888					
TITLE Semiconductor wafer grinding method					
FILING FEE RECEIVED 820	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		



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Bib Data Sheet

CONFIRMATION NO. 1912

SERIAL NUMBER 09/594,502	FILING DATE 06/16/2000 RULE	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. 47408-20007.00	
APPLICANTS Tomohiro Hashii, Imari-shi, JAPAN; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 11-170860 06/17/1999 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/28/2000					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 3	INDEPENDENT CLAIMS 1
ADDRESS 25227					
TITLE Semiconductor wafer grinding method					
FILING FEE RECEIVED 820	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		